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In the specification:

Replace the title on page 1 with the following title as follows:

--INTERFEROMETRIC STAGE METROLOGY SYSTEM--

Replace the paragraph beginning at page 1, line 4 with the following paragraph:

--This application is a continuation to United States Patent Application No. 09/853,114, filed May 10, 2001, published as U.S. Patent Application No. 2001/0035959, which in turn claims priority to United States Provisional Patent Application No. 60/205,980 filed on May 19, 2000 and United States Provisional Patent Application No. 60/212,405 filed on June 19, 2000, the contents of all of said applications are incorporated herein by reference in their entirety.--